



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date April 7, 2003

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired February 7, 2003, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 141080 in the amount of \$410.00 in payment for:

_____ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
X _____ Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
_____ Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Phillip D. Mancini

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JAO:PDM/ccs

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DEPOSIT ACCOUNT USE
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